Mission

The mission of the Connecticut State Colleges & Universities (ConnSCU) Center for Nanotechnology

is to foster collaborative, interdisciplinary research and educational initiatives/programs in micro- and nanotechnology with the goal of enhancing Connecticut's workforce competitiveness in nanotechnology and materials science. The Center builds upon existing collaborations with Yale University, The University of Connecticut and the Connecticut Community Colleges to create programs enhancing Science, Technology, Engineering, and Mathematics (STEM) education for the ConnSCU community and beyond. The ConnSCU Center for Nanotechnology is the primary resource for SCSU's Nanotechnology Graduate Certificate, the Applied Physics Masters: Nanotechnology/Materials Science track, as well as an array of research opportunities and professional development for students and faculty. Center instrumentation and programs are partially funded by grants from the National Science Foundation [NSF] and the Department of Energy [DOE].

Our Equipment

Equipment in the NanoCenter supports synthesis, processing, and characterization of micro- and nanoscale materials. Synthesis options include wet chemical methods for thin films and nanoparticles (quantum dots), and chemical vapor deposition systems for carbon nanotube (CNT) growth and thin film deposition. Transmission Electron Microscopy (TEM) sample preparation is well supported with options for polishing, milling, and slicing samples. Nanocharacterization is a strength at SCSU that is built around the data acquisition and analysis from an array of transmission, scanning electron, and force microscopy instruments. The NanoCenter is active in efforts to expand its equipment and expertise capabilities.



For more information:

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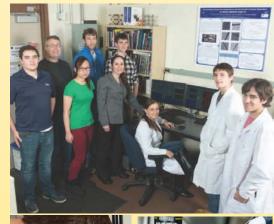


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Scanning Electron Microscopy

Zeiss Sigma VP This is a field emission SEM capable of spatial resolutions of 1.5 nm. This is a variable pressure system allowing for examination of insulating samples without addition of conducting coatings. The system contains In-lens SE, Everhart-Thornley, Backscatter and EDS detectors.



Transmission Electron Microscopy Phillips EM400

120kV TEM capable of resolving down to 0.3 nm; the system is heavily used in nano-scale investigations of interfaces and thin films. An Oxford EDX attachment is added allowing high spatial resolution elemental analysis.

Scanning Electron Microscope (tabletop) Hitachi TM1000

The system is a portable SEM with a 10,000 X magnification. Ideally suited for looking at a wide variety of small samples. It also contains an EDS detector allowing elemental composition.



Dip Pen Nanolithography (DPN) Nanoink NLP-2000 Nanolithography instrument capable of depositing a wide variety of materials with sub-micron accuracy and precision. Used for multiplexed

protein printing, biosensor functionalization, nanopattering studies, polymer pattering.

Ion Mill Gentle Mill TL-GM1 Low Energy Argon Ion bombardment beam instrument designed for preparing TEM samples to thicknesses < 100 nm.





Ultra-Microtome Sorvall Porter Ultramicrotome MT-2

Used for sectioning of polymer or biologic samples with thickness between 50 nm - 100 microns.

Chemical Vapor Deposition Carbon Nanotube Synthesis

Nanotech Innovations SSP-354 Growth of multi-wall carbon 🦼 nanotubes using a nanoparticle catalysis infused liquid precursor.





Shimadzu UV-3600 Contains three detectors and high performance double monochromator. Used for ensemble average quantum dot-size measurements.

UV-Vis-NIR

Scanning Probe Microscope (AFM and STM)

Vecco Multimode Rev 8 Nanonis RT control electronics

Atomically sharp tips raster across a sample surface generating topography map with atomic scale detail. The multimode SPM can examine conductive as well as non-conductive samples. Additionally, biological samples can be examined using a fluid cell attachment.



Optical Microscope Olympus BH2



Optical Microscopes Zeiss Axio Lab A1 and Zeiss Axio Scope A1

Allied High Tech 15-2000 GI **MultiPrep** The MultiPrep enables precise semi-automatic sample preparation

TEM Prep

Precision Low Speed A low speed saw excellent for cutting small delicate samples. Cutting of crystals and very hard materials with precision is



Inverted Optical Microscope Olympus Gx71 An inverted optical microscope for metallurgical images.

Additional Instrumentation is available to the ConnSCU Nanotechnology Center with collaboration from all Connecticut state universities. SouthernCT.edu

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